IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: ARONOWITZ et al.

Attorney Docket No.: 02-5804/LSI1P212

Application No.: 10/697,506

Examiner: CHEN, B.

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Filed: November 29, 2003

Group: 1762

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Title: VAPORIZATION AND HANDLING OF

METALS FOR USED IN SEMICONDUCTOR

PROCESSING

Confirmation No.: 8055

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AMENDMENT C

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Examiner:

This Amendment is in response to the Office Action dated August 23, 2006. The applicants wish to expressly thank Examiner Bret Chen for his moist helpful advice and guidance during an October 19, 2006 telephonic discussion of this case wherein all pending matters were discussed. Also, thanks are extended to Examiner Meeks for his help in telephonically discussing this case on 10 October 2006.

It is respectfully requested that the above-referenced patent application be reconsidered in light of the amendments and comments advanced herein below. The applicants kindly request that the Examiner amend the above-entitled application as set forth below:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

Atty Docket No.: 02-5804/LSI1P212

Page 1 of 13

Application No.: 10/697,506

PAGE 3/15 * RCVD AT 10/20/2005 5:04:39 PM [Eastern Daylight Time] * SVR:USPTO-EFXRF-6/40 * DNIS:2738300 * CSID:8316554288 * DURATION (mm-ss):05-28